DERWENT-

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ACC-NO:

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WEEK:

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TITLE:

Method to accurately define the decapsulated area of plastic package - by dropping the etching liquid in an automatic transportation manner to remove the

sealed cap portion

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PATENT-FAMILY:

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APPLICATION-DATA:

PUB-NO APPL-DESCRIPTOR APPL-NO APPL-DATE

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INT-CL (IPC): H01L023/28

ABSTRACTED-PUB-NO: TW 463340A

BASIC-ABSTRACT:

NOVELTY - A method to accurately define the decapsulated area of plastic package is disclosed, wherein a mask with a size larger than that of the plastic package is pasted on the surface of the plastic package. Next, the **decapsulated area is defined in this mask** according to the size and position of the semiconductor chip of the plastic package. Then this plastic package is heated to a specific temperature, and the etching liquid is dropped on the decapsulated area of this plastic package manually, or the etching liquid with a specific temperature is dropped on the decapsulated area of this plastic package in an automatic transportation manner to remove the sealed cap portion of the **decapsulated area** and expose the semiconductor chip. Then the semiconductor chip is cleaned.

CHOSEN- Dwg.1/1

DRAWING:

TITLE-TERMS: METHOD ACCURACY DEFINE AREA PLASTIC PACKAGE DROP ETCH LIQUID AUTOMATIC

TRANSPORT MANNER REMOVE SEAL CAP PORTION

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